



AF  
2822

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: William J. Schaff et al.

Title: AIN COATED HETEROJUNCTION FIELD EFFECT TRANSISTOR AND METHOD OF FORMING AN AIN COATING

Docket No.: 1153.044US1

Filed: May 15, 2001

Examiner: Khanh B. Duong

Serial No.: 09/858337

Due Date: March 3, 2004

Group Art Unit: 2822

MS AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

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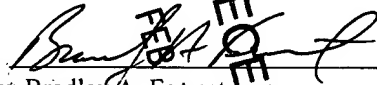
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SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

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